DRW.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Fre application of:

MARUYAMA, et al.

Atty. Docket No. 107317-00064

Serial No.:10/821,841

Examiner:

Filed: April 12, 2004

Art Unit: 2812

For: ELEC

ELECTRONIC DEVICE WITH ELECTRODE AND ITS MANUFACTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: July 29, 2004

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the information item(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each item(s) is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the item(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

merits	This Information Disclosure Statement is being filed (a) within three months U.S. filing date, OR (b) before the mailing date of a first Office Action on the in the present application, OR (c) accompanies a Request for Continued nation. No certification or fee is required.
2. after the merits,	This Information Disclosure Statement is being filed more than three months ne U.S. filing date AND after the mailing date of the first Office Action on the but before the mailing date of a Final Rejection or Notice of Allowance.
	a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).
	b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(2).

	c. A check in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please charge any fee deficiency or credit any overpayment to Deposit Account No. 01-2300 as needed to ensure consideration of the disclosed information.
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	b. I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(2).

Respectfully submitted,

Wilburn L. Chesser Registration No. 41,668

Customer No. 004372 ARENT FOX PLLC 1050 Connecticut Avenue, N.W., Suite 400 Washington, D.C. 20036-5339

Tel: (202) 857-6000 Fax: (202) 638-4810

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Enclosures: Communication from European Patent Office dated July 1, 2004

European Search Report

Form PTO-1449 References (8) JUL 2 9 2004 E

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Sheet 1 of 1

ATTY. DOCKET NO. SERIAL NO.

107317-00064 10/821.841

APPLICANT

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

MARUYAMA, et al.

FILING DATE GROUP

April 12, 2004 2812

U.S. PATENT DOCUMENTS

	T	T	T				
EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
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 АН	EP 0795 898 A2	March 10, 1997	Europe					
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

,	АМ	P.C. Van Buskirk et al., "Common and Unique Aspects of Perovskite Thin Film CVD Processes" Integrated Ferroelectrics, Vol. 21, pgs. 273-289, (1998).
	AN	
	AO	

EXAMINER		DATE CONSIDERED
*EXAMINER:	Initial if reference considered, whether or not citation is in conformance and not considered. Include copy of this for	n conformance with MPEP 609; Draw line through citation if not in